

Application No.: 10/721,391

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Docket No.: 495152000402

Amendments to the Specification:

Please replace the paragraph inserted before the title "BACKGROUND OF THE INVENTION" on page 1 of the specification by way of the earlier filed first Preliminary Amendment with the following amended paragraph:

This application is a continuation of U.S. Patent Application Serial No. 09/856,855, titled METHODS AND APPARATUS FOR HOLDING AND POSITIONING SEMICONDUCTOR WORKPIECES DURING ELECTROPOLISHING AND/OR ELECTROPLATING OF THE WORKPIECES, filed on November 24, 1999, which is a 371 of PCT/US99/28106, filed on November 24, 1999, which claims benefit of U.S. Provisional Patent Application Serial No. 60/110,436 ~~134~~, filed on November 28, 1998, the entire contents of each of these applications are incorporated herein by reference.

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